

Docket No.: 21776-00042-US1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Nobuhiro Miki et al.

Application No.: 10/656,190

Confirmation No.: 8417

Filed: September 8, 2003

Art Unit: 1746

For: SURFACE PURIFICATION APPARATUS
AND SURFACE PURIFICATION METHOD

Examiner: M. Kornakov

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION (RCE)

MS RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action mailed May 10, 2007 and Advisory Action mailed August 15, 2007, please amend the above referenced application as follows:

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.